

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/763,578	Confirmation No.:	4912
Applicant	:	ROBERT W. BOWER		
Title	:	STRUCTURES, MATERIALS AND METHODS FOR FABRICATION OF NANOSTRUCTURES BY TRANSPOSED SPLIT OF ION CUT MATERIALS		
Filed	:	01/21/2004		
TC/A.U.	:	2823		
Examiner	:	JEFFERSON, QUOVAUNDA		
Docket No.	:	BOW5075.14A1		
Cust. No.	:	8156		

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed on February 6, 2007, please amend the above-identified U.S. patent application as follows. The required petition and fee for a one-month extension of time is submitted herewith.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.